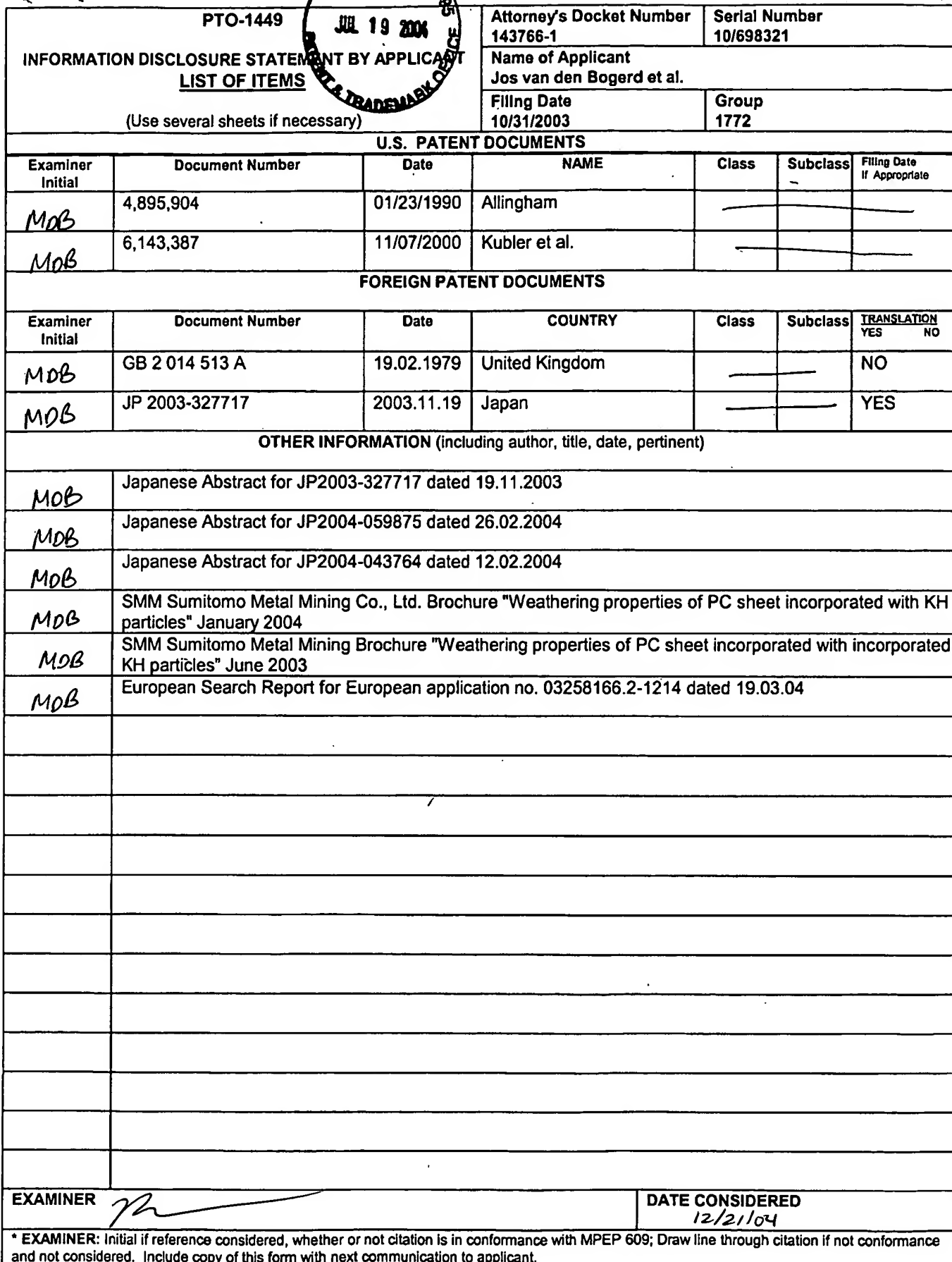


PTO-1449			Attorney's Docket Number 143766-1		Serial Number 10/698321	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <b>LIST OF ITEMS</b>			Name of Applicant Jos van den Bogerd et al.			
(Use several sheets if necessary)			Filing Date 10/31/2003		Group 1772	
<b>U.S. PATENT DOCUMENTS</b>						
Examiner Initial	Document Number	Date	NAME	Class	Subclass	Filing Date if Appropriate
MOB	3,885,855	05/27/1975	Gross			
MOB	4,323,668	04/06/1982	Brunelle			
MOB	5,405,680	04/11/1995	Chang et al.			
MOB	6,060,154	05/09/2000	Adachi et al.			
MOB	US 6,221,945 B1	04/24/2001	Kuno et al.			
MOB	US 6,277,187 B1	08/21/2001	Kuno et al.			
MOB	US 6,319,613 B1	11/20/2001	Takeda et al.			
MOB	US 6,420,512 B1	07/16/2002	McCloskey et al.			
MOB	US 6,548,623 B2	04/15/2003	Brunelle et al.			
MOB	US 6,620,872 B2	09/16/2003	Fisher			
MOB	US 2003/0054160 A1	03/20/2003	Fisher et al.			
<b>FOREIGN PATENT DOCUMENTS</b>						
Examiner Initial	Document Number	Date	COUNTRY	Class	Subclass	TRANSLATION YES NO
MOB	EP 0 454 349 A2	17.04.91	European			NO
MOB	EP 0 727 306 A2, B1	22.01.96	European			NO
MOB	EP 0 905 100 B1	15.09.98	European			NO
MOB	EP 0 943 587 A1	29.10.98	European			NO
MOB	EP 1 008 564 A1	09.12.99	European			NO
MOB	WO 02/060988 A1	08.08.02	International			NO
MOB	GB 2 057 355 A	28.08.80	Great Britain			NO
MOB	JP 06-122803	06.05.94	Japan			YES
MOB	JP 07-070356	14.03.95	Japan			YES
MOB	JP 08-104835	23.04.96	Japan			YES
MOB	JP 09-063117	07.03.97	Japan			YES
MOB	JP 2000-072484	07.03.00	Japan			YES
EXAMINER <i>[Signature]</i>				DATE CONSIDERED 12/21/04		

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.



<b>PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <b>LIST OF ITEMS</b> (Use several sheets if necessary)			<b>Attorney's Docket Number</b> 143766-1		<b>Serial Number</b> 10/698321	
<div style="position: absolute; left: -100px; top: 0; border: 1px solid black; border-radius: 50%; padding: 5px; text-align: center;">             OIP              FEB 20 2004              PATENT           </div>			<b>Name of Applicant</b> Jos van den Bogerd et al.			
			<b>Filing Date</b> 10/31/2003		<b>Group</b> 1772	
<b>FOREIGN PATENT DOCUMENTS</b>						
Examiner Initial	Document Number	Date	COUNTRY	Class	Subclass	TRANSLATION YES NO
Mob	JP 2000-096034	04.04.00	Japan	—	—	YES
Mob	JP 2000-319554	21.11.00	Japan	—	—	YES
Mob	JP 2001-089202	03.04.01	Japan	—	—	YES
Mob	JP 2002-369629	24.12.02	Japan	—	—	YES
<b>OTHER INFORMATION</b> (including author, title, date, pertinent)						
Mob	Japanese Abstract for JP2000319554A 2000.11.21					
Mob	Schelm et al. "Dilute LaB <sub>6</sub> nanoparticles in polymer as optimized clear solar control glazing" Applied Physics Letters, Volume 82, Number 24, June 16, 2003 pp. 4346-4348					
Mob	SMM Sumitomo Metal Mining Brochure "A new IR-active agent to screen out solar heat 'KH'" Sumitomo Metal Mining Co., Ltd., Performance Materials Dept., 11-3 Shimbashi, 5-chome, Tokyo 105-8716 Japan - www.smm.co.jp					
Mob	SMM Sumitomo Metal Mining Brochure "IR-Shielding Dispersions" Sumitomo Metal Mining Co., Ltd., Performance Materials Dept., 11-3 Shimbashi, 5-chome, Tokyo 105-8716 Japan - www.smm.co.jp					
<b>EXAMINER</b>					<b>DATE CONSIDERED</b>	
					12/21/04	
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